



SMINT.049AUS

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Granneman, Ernst H.A.
Appl. No. : 10/728,126
Filed : December 3, 2003
For : APPARATUS AND METHOD
FOR ATOMIC LAYER
DEPOSITION ON SUBSTRATES
Examiner : Karla A. Moore
Group Art Unit : 1763

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

7/26/06
(Date)

Zi Y. Wong, Reg. No. 58,110

RESPONSE TO FINAL OFFICE ACTION

Mail Stop AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

In response to the Final Office Action mailed May 30, 2006, Applicants request full consideration of the remarks herein.

A Listing of the Claims begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.

PLEASE ENTER 8/7/06